



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 8728**
Norio KIMURA et al. : Docket No. 2000-1761A
Serial No. 09/742,386 : Group Art Unit 1763
Filed December 22, 2000 : Examiner Karla A. Moore
APPARATUS AND METHOD FOR : **MAIL STOP: AMENDMENT**
PROCESSING SEMICONDUCTOR
SUBSTRATE

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of March 28, 2005, the period for response to which having been extended by one month to July 28, 2005, kindly amend the above-referenced U.S. patent application as follows:

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

07/29/2005 HALI11 00000095 09742386

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